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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re PATENT application of:

Shunpei YAMAZAKI et al.

Serial No. 09/295,607

Filed: 04/22/1999

For: SEMICONDUCTOR DEVICE HAVING

ALUMINUM NITRIDE FILM

Art Unit: 2811

Examiner: S. Loke

#34/ID
5-24-2
Suler

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 5/13/2002.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks

Washington, D.C. 20231

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MAY 20 2002**BEST AVAILABLE COPY**

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a). The requisite fee of \$180.00 is also submitted herewith in accordance with 37 C.F.R. 1.97(c). The enclosed references were cited in a counterpart Japanese patent application .

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

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180.00 OP

Respectfully submitted,

Luan Do
Reg. No. 38,434

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110